

1. Record Nr.	UNINA9910703291903321
Titolo	Imaging study of multi-crystalline silicon wafers throughout the manufacturing process [[electronic resource]] : preprint // Steve Johnston ... [and others]
Pubbl/distr/stampa	[Golden, CO] : , : National Renewable Energy Laboratory, , [2011]
Descrizione fisica	1 online resource (6 pages) : illustrations (some color)
Collana	NREL/CP ; ; 5200-50724
Altri autori (Persone)	JohnstonSteve
Soggetti	Silicon solar cells - Design and construction - Testing Photoluminescence
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Monografia
Note generali	Title from title screen (viewed August 8, 2011). "July 2011." "Presented at the 37th IEEE Photovoltaic Specialists Conference (PVSC 37), Seattle, Washington, June 19-24, 2011."
Nota di bibliografia	Includes bibliographical references (page 6).